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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Leah Markowitz, et al.

Application No.: 10/613,849

Group No.: 2814

Filing Date: 7/3/2003

Examiner: Anh D. Mai

For: "Transparent Inter-Metal Dielectric Stack For CMOS Image Sensors"

Date: September 14, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS INQUIRY

1. More than twelve months have passed since the filing of this application on July 3, 2003. No communication has been received from the Patent and Trademark Office indicating action on this application.
2. Kindly advise the undersigned of the present status of this application.


SIGNATURE OF PRACTITIONER

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